

Case Docket No. ASMEX.291A Date: November 25, 2002

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s)	:	Todd et al.	I hereby certify that this correspondence and all marked attachments are being deposited with the United States Postal Service as first class mail in an envelope addressed to: United States Patent and Trademark Office, P.O. Box 2327, Arlington, VA 22202, on  November 25, 2002  (Date)  Joseph J. Mallon, Reg. No. 39,287
Appl. No.	:	10/074,563	
Filed	:	February 11, 2002	
For	:	PROCESS FOR DEPOSITION OF SEMICONDUCTOR FILMS	
Examiner	:	Unknown	
Group Art Unit:		1762	)

## TRANSMITTAL LETTER

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Dear Sir:

Enclosed for filing in the above-identified application are:

- (X) An Information Disclosure Statement.
- (X) A PTO Form 1449 with three (3) references.
- (X) The Commissioner is hereby authorized to charge any additional fees which may be required, or credit any overpayment, to Account No. 11-1410.
- (X) Return prepaid postcard.

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